



Filed Via Express Mail pursuant to 37 C.F.R. 1.10
Record No. KV 73274329545
On: Nov - 28 - 05
By: Patricia Muir
Patricia Muir

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Yoshihisa MATSUBARA et al.
Serial No.: 09/840,386
Filed: April 23, 2001
Title: **METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE, AND PROCESSING SYSTEM AND
SEMICONDUCTOR DEVICE**
Examiner: Lan Vinh
Group Art Unit: 1765
Confirmation No.: 2510
Attorney Docket No.: 100806-00199 (NEKA 18.612)

November 28, 2005

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Sir:

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

() one month () three months
(X) two months () four months

The fee set in 37 CFR 1.17 for a two-month extension of time is \$450.

☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☒ Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☐ Applicant is a small entity entitled to pay reduced fees in this application.

A verified small entity statement:

☐ has been filed ☐ is enclosed.

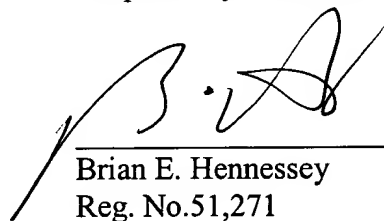
Also enclosed is a:

☐ Election

☒ Notice of Appeal

☒ Response/ Amendment

Respectfully submitted,



Brian E. Hennessey
Reg. No. 51,271

CUSTOMER NUMBER 026304

KATTEN MUCHIN ROSENMAN
575 Madison Avenue
New York, NY 10022-2585
(212) 940-8800
Docket No.: NEKA 18.612
BEH: pm